



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG831633961
Report verification at igi.org

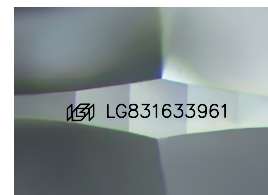
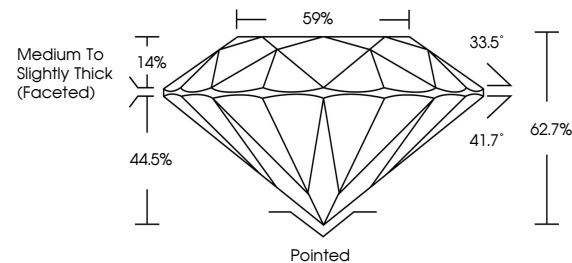
August 27, 2026	
IGI Report Number	LG831633961
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.38 - 7.42 X 4.64 MM
GRADING RESULTS	
Carat Weight	1.56 CARAT
Color Grade	E
Clarity Grade	VS 1
Cut Grade	EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG831633961

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

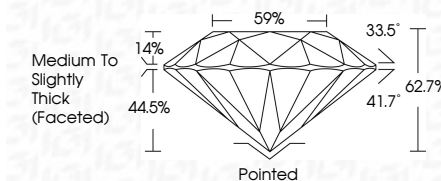
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

August 27, 2026
ICI Report No LG831633961
ROUND BRILLIANT

ROUND BRILLIANT	7.38 - 7.42 X 4.64 MM	1.56 CARAT E
Color Grade	VS 1	EXCELLENT
Clarity Grade	VS 1	EXCELLENT
Cut Grade	62.7%	59%
Depth	Medium to Slightly Thick	Focused
Table	Polished	EXCELLENT
Girdle	EXCELLENT	EXCELLENT
Culet	Symmetry	NONE
Polish	Fluorescence	

Comments:
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